

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. : 10/809,021 Confirmation : 7807  
Applicant(s) : Ryo EDO  
Filed : March 24, 2004  
Title : LOAD-LOCK SYSTEM, EXPOSURE PROCESSING SYSTEM, AND  
DEVICE MANUFACTURING METHOD

Art Unit : 1724  
Examiner : Minh Chau Thi PHAM

Docket No. : 1232-5355  
Customer No. : 27123

**AMENDMENT UNDER 37 C.F.R. 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is being filed in response to the non-final Office Action dated  
May 17, 2006. This paper is set forth as follows:

- **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.
- **Remarks** begin on page 6 of this paper.